

RECEIVED

Atty Dkt 40972039-2

APR 20 1999

5000-0016

PATENT

Op 1752

GROUP 1700

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231 on February 4, 1999

2/4/99

Date

Gail Wardwell

Signature

RECEIVED

FEB 12 1999

GROUP 1700

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:

BRENNEN et al.

Serial No.: 09/233,694

Group Art Unit: Unassigned

Filing Date: January 19, 1999

Examiner: Unassigned

Title: METHOD FOR PRODUCING HIGH-SURFACE AREA TEXTURING OF A
SUBSTRATE, SUBSTRATES PREPARED THEREBY AND MASKS FOR
USE THEREIN



TRANSMITTAL LETTER

Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

Transmitted herewith for filing is an Information Disclosure Statement, including a Form PTO-1449 and copies of the cited references. It is believed that no fee is due.

The Commissioner is hereby authorized to charge any fees under 37 C.F.R. §§ 1.16, 1.17 and 1.21 which may be required by this paper, or to credit any overpayment, to Deposit Account No. 18-1648.

Respectfully submitted,

Date:

4 Feb 1999

By:

Kenneth Barovsky

Kenneth Barovsky

Registration No. 36,442

Attorney for Applicants

HEWLETT-PACKARD COMPANY
Legal Department
3000 Hanover Street, MS 20BO
Palo Alto, CA 94304
Telephone: 650-857-4316
Facsimile: 650-852-8063

#2

RECEIVED
APR 20 1999
GROUP 1700

Atty Dkt 10972039-2
5000-0016
PATENT

RECEIVED
APR 12 1999

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231 on February 4, 1999.
2/4/99 Gail Wardwell
Date Signature

GROUP 1700



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:

BRENNEN et al.

Serial No.: 09/233,694 Group Art Unit: Unassigned

Filing Date: January 19, 1999 Examiner: Unassigned

Title: METHOD FOR PRODUCING HIGH-SURFACE AREA TEXTURING
OF A SUBSTRATE, SUBSTRATES PREPARED THEREBY AND
MASKS FOR USE THEREIN

INFORMATION DISCLOSURE STATEMENT
UNDER 37 C.F.R. § 1.97

Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

The information listed below may be material to the examination of the above-identified application. Copies of the information and completed PTO-1449 forms are submitted herewith. The Examiner is respectfully requested to make this information of official record in the application. The information includes:

- U.S. Patent No. 4,478,677 issued October 23, 1984 to Chen et al.;
- U.S. Patent No. 4,490,210 issued December 25, 1984 to Chen et al.;
- U.S. Patent No. 4,490,211 issued December 25, 1984 to Chen et al.;
- U.S. Patent No. 4,923,772 issued May 8, 1990 to Kirch et al.;

U.S. Patent No. 5,500,071 issued March 19, 1996 to Kaltenbach et al.;
U.S. Patent No. 5,571,410 issued November 5, 1996 to Swedberg et al.;
U.S. Patent No. 5,658,413 issued August 19, 1997 to Kaltenbach et al.;
Japanese Publication No. 7-241690 published September 19, 1995 (English
language abstract);

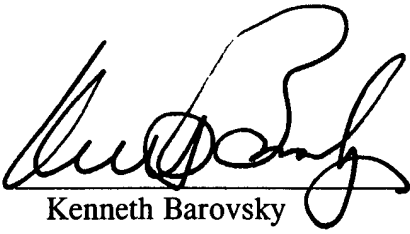
Japanese Publication No. 7-80675 published March 28, 1995 (English
translation); and

Krajnovich et al., "Formation of 'Intrinsic' Surface Defects During 248 nm
Photoablation of Polyimide," *J. Appl. Phys.* 73:3001-3008 (1993).

This Information Disclosure Statement under 37 CFR § 1.97 is not to be
construed as a representation that: (i) a complete search has been made; (ii) additional
information material to the examination of this application does not exist; (iii) the
information, protocols, results and the like reported by third parties are accurate or
enabling; or (iv) the above information constitutes prior art to the subject invention.

Respectfully submitted,

Date: 4 Feb 1999

By: 
Kenneth Barovsky
Registration No. 36,442
Attorney for Applicants

HEWLETT-PACKARD COMPANY
Legal Department
3000 Hanover Street, MS 20BO
Palo Alto, CA 94304
Telephone: 650-857-4316
Facsimile: 650-852-8063